



QP-2125
Jfw ✓

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Dayton, Ohio

Docket No. 10994

Application of:

DURRANT, D. J. et al.

Group Art Unit: 2125

Serial No. 09/541,137

Examiner: RAO, SHEELA S.

Filed: March 31, 2000

For: **METHOD AND SYSTEM FOR IDENTIFYING MANUFACTURING
ANOMALIES IN A MANUFACTURING SYSTEM**

Assistant Commissioner for Patents

Washington, D.C. 20231

RESPONSE

Sir:

In response to the Office Action dated May 3, 2004, kindly enter the following reply.

No changes to the claims are presented in this reply. However, a listing of the claims in their present state is provided immediately below for the convenience of the Examiner.

08/09/2004 BSAYAS11 00000006-501673-09541137-

01-FC-1814 110-00-DA

CERTIFICATION OF MAILING UNDER 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

Aug 3, 2004.

By: Sallie Spicer
Name: Sallie Spicer